



PATENT
Attorney Docket No. 01-099
Express Mail Lab 1 No. EV417741166US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Rongxiang Hu, Philippe Schoenborn,)
and Masaichi Eda)
Serial No. 09/928,570)
Filed: August 13, 2001)
For: HIGH SELECTIVELY SiC ETCH)
IN INTEGRATED CIRCUIT)
FABRICATION)

Group Art Unit: 1765
Confirmation No. 7873
Examiner: L. Umez-Eronini
AFTER FINAL

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DEC 23 2003

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AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action mailed October 22, 2003, please amend the application as set forth below in the Two Parts of this Amendment and Response.

IN THE CLAIMS:

Amend claim 1 as shown in Part 1 hereof.

REMARKS:

Part 2 comments on the above amendment, and the October 22, 2003 office action.